

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10816385	
	Filing Date		2004-04-01	
	First Named Inventor	Feng-Wen Sun		
	Art Unit	2461		
	Examiner Name	HAILU, Kibrom T.		
Attorney Docket Number		PD-203051		

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Chinese Rejection Decision dated January 26, 2011 in Chinese Patent Application No. 200410049082.5 filed June 11, 2004 by Feng-Wen Sun et al.



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